

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Horning et al.

Attorney Docket No. H16-16009
HOOO-1-1200

Serial No.: 09/873,931

Group Art Unit: 2814

Filing Date: June 4, 2001

Examiner: RAO, Shrinivas

Title: APPLICATIONS OF A STRAIN-COMPENSATED HEAVILY DOPED ETCH
STOP FOR SILICON STRUCTURE FORMATION

PETITION FOR EXTENSION OF TIME AND PAYMENT OF FEE

TO THE COMMISSIONER FOR PATENTS:

This is a petition for an extension of time for a total period of one month to respond to the pending Office Action. A response to the outstanding Office Action is also enclosed.

Charge Credit Card account in the amount of \$120 for the one month extension fee as well as \$790 for the RCE fee.

Charge any applicable correction fees or credit any overpayment, to deposit account No. 501050. *A duplicate copy of this sheet is provided.*

Respectfully submitted,

BLACK LOWE & GRAHAM^{PLLC}



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